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PATENT

Attorney Docket No.: 17620R-002600US

Client Ref. No.: 900035US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ta-Chung Wu *et al.*

Application No.: 10/668,454

Filed: September 22, 2003

For: METHOD OF FORMING
BOTTOM OXIDE LAYER IN
TRENCH STRUCTURE

Customer No.: 20350

Confirmation No.: 2352

Examiner: Khiem D. Nguyen

Technology Center/Art Unit: 2823

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2823**

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed November 2, 2004 on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

PLEASE ENTER
K.N.
12/28/04